



2020 ACM International Symposium on Physical Design
Wafer-Scale Deep Learning
Accelerator Placement Contest

FIRST PLACE

Team Ripplewafer

Bentian Jiang, Jingsong Chen, Jinwei Liu, Xiaopeng Zhang,
Fangzhou Wang, Lixin Liu, Evangeline F.Y. Young
[The Chinese University of Hong Kong](#)

William Swartz
General Chair
ISPD2020

Jens Lienig
Technical Program Chair
ISPD2020

Marvin Tom, Michael James,
Vladimir Kibardin, Robby Fry,
Patrick Groeneveld,
Cerebras